

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Wen-Jian Lin
Appl. No.	:	10/810,660
Filed	:	March 29, 2004
For	:	STRUCTURE OF A MICRO ELECTRO MECHANICAL SYSTEM AND THE MANUFACTURING METHOD THEREOF
Examiner	:	Jarrett J. Stark
Group Art Unit	:	2823

AMENDMENT**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 18, 2006, please find the enclosed amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.